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CONFIRMATION NO. 7802

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Takako Yamaguchi, Atsugi-shi, JAPAN; Yasuhisa Inao, Kanagawa-ken, JAPAN; ** CONTINUING DATA ***************** This application is a 371 of PCT/JP04/09375 06/25/2004 ** FOREIGN APPLICATIONS ************************************								
Foreign Priority claimed			STATE OR COUNTRY JAPAN	DRAWING CLA		TOT. CLAI 14	MS	INDEPENDENT CLAIMS 7
ADDRESS 5514 TITLE Exposure mask, method of designing and manufacturing the same, exposure method and apparatus, pattern forming method, and device manufacturing method								
FILING FEE FEE	FILING FEE FEES: Authority has been given in Paper RECEIVED No to charge/credit DEPOSIT ACCOUNT				All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other Credit			